

Notice of References Cited	Application/Control No. 10/735,956	Applicant(s)/Patent Under Reexamination HATSCH ET AL.	
	Examiner Tan V Mai	Art Unit 2193	Page 1 of 1

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	B	US-6,578,063	06-2003	Kojima et al.	708/709
	C	US-2002/0038327	03-2002	Ferroussat, Sebastien	708/708
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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